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Docket No.: SON-2782
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Minoru Sugawara

Application No.: 10/519,449

Confirmation No.: 9573

Filed: December 30, 2004

Art Unit: 1756

For: RECORDING APPARATUS, RECORDING
METHOD, REPRODUCING APPARATUS,
REPRODUCING METHOD AND
RECORDING MEDIUM

Examiner: S. D. Rosasco

STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that the attorney named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive an Office Action from the Patent and Trademark Office.

Applicant believes no fee is due with this response. However, if a fee is due, please charge our Deposit Account No. 18-0013, under Order No. SON-2782 from which the undersigned is authorized to draw.

Dated: January 16, 2007

Respectfully submitted,

By

Ronald P. Kananeh

Registration No.: 24,104

RADER, FISHMAN & GRAUER PLLC

Correspondence Customer Number: 23353

Attorney for Applicant

Search results as of: 01-11-2007::15:18:28 E.T.

Bibliographic Data

Application Number:	10/519,449	Customer Number:	-
Filing or 371 (c) Date:	08-25-2005	Status:	Docketed New Case - Ready for Examination
Application Type:	Utility	Status Date:	02-27-2006
Examiner Name:	ROSASCO, STEPHEN D	Location:	ELECTRONIC
Group Art Unit:	1756	Location Date:	-
Confirmation Number:	9573	Earliest Publication No:	US 2006-0099517 A1
Attorney Docket Number:	SON-2782	Earliest Publication Date:	05-11-2006
Class / Subclass:	430/005	Patent Number:	-
First Named Inventor:	Minoru Sugawara , Kanagawa, (JP)	Issue Date of Patent:	-

Title of Invention:	Phase shift mask fabrication method thereof and fabrication method of semiconductor apparatus
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Issue Fee